



FRW

PATENT  
Customer No. 22,852  
Attorney Docket No. 04329.3238

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	)	
Gaku MINAMIHABA et al.	)	Group Art Unit: 2818
	)	
Application No. 10/771,060	)	Examiner: Goodwin, David J.
	)	
Filed: February 4, 2004	)	Confirmation No. 2231
	)	
For: POLISHING PAD AND METHOD	)	
OF MANUFACTURING	)	
SEMICONDUCTOR DEVICES	)	

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**REQUEST FOR RECONSIDERATION**

In reply to the Office Action mailed November 14, 2005, with a period for response extending through February 14, 2006, Applicants request the Examiner's reconsideration in view of the remarks beginning at page 2 of this paper. Applicants are also submitting an information disclosure statement (IDS) concurrently herewith.